

<b>Notice of References Cited</b>	Application/Control No. 10/661,675	Applicant(s)/Patent Under Reexamination OHBA ET AL.	
	Examiner Phu K. Nguyen	Art Unit 2673	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	<del>US-6,850,243</del>	<del>02-2005</del>	<del>Kilgariff et al.</del>	<del>345/582</del>
	B	<del>US-6,778,181</del>	<del>08-2004</del>	<del>Kilgariff et al.</del>	<del>345/582</del>
	C	<del>US-6,603,874</del>	<del>08-2003</del>	<del>Stern et al.</del>	<del>382/144</del>
	D	<del>US-6,897,394</del>	<del>08-2000</del>	<del>Levoy et al.</del>	<del>345/419</del>
	E	<del>US-5,947,819</del>	<del>09-1999</del>	<del>Ohshima, Naoto</del>	<del>453/2</del>
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	TAKAGI et al., "A Learning Support System for Beginners in Pencil Drawing," ACM, 10/2003, pp. 281-282.
	V	HAEBERLI et al., "The Accumulation Buffer: Hardware Support for High-quality Rendering," Computer Graphics (SIGGRAPH 1990 Proceedings), volume 24, no. 4, pp. 309-318, 8/1990
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.